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Image

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In re Patent Application of: Michael Weber-Grabau et al.

Atty Docket No. TWI-31000

Application No.: 09/927,102

Filed: August 10, 2001

For: OPTICAL CRITICAL DIMENSION METROLOGY SYSTEM INTEGRATED INTO
SEMICONDUCTOR WAFER PROCESS TOOL

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmittal herewith is an amendment in the above-identified application.

The fee has been calculated as shown below.

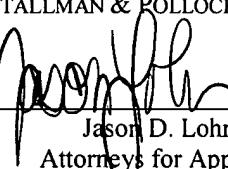
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL	44	MINUS	42	2	x \$18 =	\$36
INDEP.	6	MINUS	4	2	x \$86 =	\$172
FIRST PRESENTATION OF MULTIPLE DEP CLAIMS						+ \$290
						TOTAL \$208

Small Entity 50% Filing Fee Reduction (if applicable) \$104

* If the entry in Col. 1 is less than the entry in Col. 2, write "0" in Col. 3
** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.
*** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space. The "Highest Number Previously Paid For" (Total or Independent is the highest number found from the equivalent box in Col. 1 of a prior amendment or the number of claims originally filed.)

- No additional fee is required.
- A check in the amount of \$104.00 is attached.
- Please charge any additional fees, including any fees necessary for extensions of time or credit overpayment to Deposit Account No. 50-1703, under Order No. TWI-31000.
A duplicate copy of this sheet is enclosed.
- Petition for extension of time. The undersigned attorney of record hereby petitions for an extension of time pursuant to 37 C.F.R. § 1.136(a), as may be required, to file this response.

Dated: 12/15/03

By: 

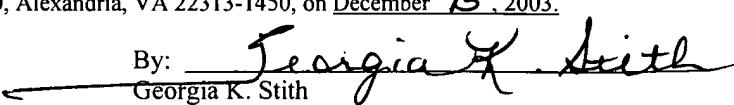
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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on December 15, 2003.

Dated: December 15, 2003

By: 
Georgia K. Stith